

<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  <b>(PTO-1449)</b>				ATTY. DOCKET NO. <b>K-2150</b>		U.S. PATENT APPLICATION NO. <b>10/786,084</b>	
				APPLICANT <b>Kensuke Matsui</b>			
				FILING DATE <b>February 26, 2004</b>		GROUP <b>1754</b>	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	JP2001-130990	05/15/2001	Japan	X	X	Abstract	
	JP 2002-205026	07/23/2002	Japan			Abstract	
	JP H02-504359 (WO88/09316)	12/13/1990 (12/01/1988)	Japan (PCT)			X	
	JP S49-24757	03/06/1974	Japan				X
	JP2002-028608	01/29/2002	Japan			Abstract	
	JP2001-353499	12/25/2001	Japan			Abstract	
	JPH04-338300	11/25/1992	Japan			Abstract	
	JPH04-507233 (WO91/02550)	12/17/1992 (03/07/1991)	Japan (PCT)			Abstract	
	JPS58-117988	07/13/1983	Japan				X
	JPH11-159957	06/15/1999	Japan			Abstract	
	WO 02/24585	03/28/2002	PCT			X	
	JP2001-153555	06/08/2001	Japan			Abstract	
	JPH07-136696	05/30/1995	Japan			Abstract	
	JP2004-508930 (WO02/24585)	03/25/2004 (03/28/2002)	Japan (PCT)			Abstract	
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
EXAMINER			DATE CONSIDERED				
/Kevin Joyner/			03/21/2008				

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /KCJ/